

101437220

..... OFFICE

U

Case Docket No. <u>000979</u>

U.S. DEPARTMENT OF COMMERCE

Patent and Trademark Office

RECORDATION FORM COVER SHEET

PATENTS ONLY

\$. 3.00

09/63/834

To the Director of Patents and Trademarks.

Please record the attached original documents or copy thereof.

1. Name of conveying party(ies):

Manabu HAYASHI

Additional name(s) of conveying party(ies) attached? NO

2. Name and address of receiving party(ies):

Name: FUJITSU LIMITED

Street Address: 1-1, Kamikodanaka 4-chome, Nakahara-ku

Kawasaki-shi, Kanagawa 211-8588, JAPAN

Additional name(s) & address(es) attached? NO

3. Nature of conveyance: Assignment

Execution Date: July 25, 2000

4. Title: SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING THE

SAME

5. Application number(s) or patent number(s):

If this document is being filed together with a new application, the execution date of the application is: <u>July 25, 2000</u>

A. Patent Application No.(s)

B. Patent No.(s)

Additional numbers attached? NO

08/14/2000 JWGSHING 0000067 09631834 03 FC:581 40

40.8

PATENT

REEL: 010998 FRAME: 0321

6. Name and address of party to whom correspondence concerning document should be mailed: Name: Armstrong, Westerman, Hattori, McLeland & Naughton **Suite 1000** 1725 K Street, N.W. Washington, D.C. 20006 7. Total number of applications and patents involved: 1 XX Check enclosed 9. Deposit Account No.: <u>01-2340</u> 10. Statement and signature. To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is a true copy of the original document. Date August 3, 2000 Donald W. Hanson Reg. No.: 27,133 Total number of pages including cover sheet: 3

DWH/11

PATENT REEL: 010998 FRAME: 0322

Armstrong, Westerman, Hattori, McLeland & Naughton

U.S. ASSIGNMENT

	IN CONSIDERATION of the su consideration paid to the undersigned					
(Insert ASSIGNEE's Name(s) Address(es))	FUJITSU_LIMITED 1-1, Kamikodanaka 4-chome, Nakahara-ku, Kawasaki-shi, Kanagawa 211-8588 Japan					
	(hereinafter ASSIGNEE), the receipt of which is hereby acknowledged, the undersigned ASSIGNOR hereby sells, assigns and transfers to ASSIGNEE the entire and exclusive right, title and interest to the invention entitled					
(Title of Invention)	SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING THE SAME					
(*If the assignment is being filed after the filing of the application, this section must be completed)	for which application for Letters Patent of the United States was executed on even date herewith unless otherwise indicated below:					
	'filed on, Serial No					
				litigation, or other legal proceeding continuation, divisional, reissue or thereon and to cooperate with the evidence and proceeding with such	reexamination thereof or Letters P ASSIGNEE in every way possible	ning this application or any atent or reissue patent issued in obtaining and producing gal proceeding.
				(Signatures)	Manabu Nayashi (SIGNATURE)	Manabu Hayashi
	(SIGNATURE)	(TYPE NAME)				
(SIGNATURE)	(TYPE NAME)	(DATE)				
(SIGNATURE)	(TYPE NAME)	(DATE)				
(SIGNATURE)	(TYPE NAME)	(DATE)				
(SIGNATURE)	(TYPE NAME)	(DATE)				
(SIGNATURE)	(TYPE NAME)	(DATE)				
(SIGNATURE)	(TYPE NAME)	(DATE)				
(SIGNATURE)	(TYPE NAME)	(DATE)				
	(SIGNATURE)	(TYPE NAME)	(DATE)			
	NO LEGALIZATION REQUIRED					

Rev. #2 10/92

RECORDED: 08/03/2000

PATENT REEL: 010998 FRAME: 0323

Docket No.